



501.39155VC2

*IPW*  
*[Signature]*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): M. MASUDA et al  
Serial No.: 10/743,882  
Filed: December 24, 2003  
For: A SEMICONDUCTOR DEVICE AND A METHOD OF  
MANUFACTURE  
Group: 2815  
Examiner: S. CLARK

**AMENDMENT**

**MS: AMENDMENT**

Commissioner For Patents  
POB 1450  
Alexandria, VA 22313-1450

December 22, 2004

Sir:

In response to the outstanding Office Action, dated September 22, 2004,  
please amend the above-identified application as listed below and as set forth on  
the following pages:

**Amendments to the Claims.**

**Remarks** are included following the Amendments.

12/23/2004 NNGUYEN1 00000076 10743882

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